

312-102



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Docket No. 0756-958

32/H
9-4-96
C. Brown

CERTIFICATE OF MAILING

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Deborah J. Tomme
Deborah T. Tomme

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re PATENT application of:)
Shunpei YAMAZAKI et al.)
Serial No. 08/183,800) Examiner Saad
Filed: January 21, 1994) Art Unit: 2508
For: SEMICONDUCTOR MATERIAL)
AND METHOD FOR FORMING)
THE SAME AND THIN FILM)
TRANSISTOR) August 5, 1996

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AMENDMENT

Honorable Assistant Commissioner for Patents

Washington, D.C. 20231

Sir:

In response to the Office Action mailed March 5, 1996, please amend the above-identified application as follows.

IN THE CLAIMS:

Please amend claims 23-35 as follows:

23. (Three Times Amended) A thin film transistor comprising:

[an intrinsic channel] a semiconductor layer having an intrinsic

or substantially intrinsic channel region;

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